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Bib Data Sheet

CONFIRMATION NO. 5417

SERIAL NUME 09/900,165		FILING DATE 07/09/2001 RULE		CLASS 718 700	GROUP ART UNIT		ATTORNEY DOCKET NO. 07942.0007			
APPLICANTS										
Neal Kuo,	Chia-	yi City, TAIWAN;		•						
** CONTINUING	DATA	4 **********	•							
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** FOREIGN APPLICATIONS ************************************										
01 III II 333 1 101 00 00/ 14/2000										
IF REQUIRED, FOREIGN FILING LICENSE GRANTED										
** 08/21/2001										
Foreign Priority claimed yes no							TOTA		MDERENDENT	
35 USC 119 (a-d) conditions West after COLINTRY DRA						AWING CLAIR 3 17		. —		
met Allowance TAIWAN									4	
Acknowledged Examiner's Signature Initials										
ADDRESS										
22852										
TITLE										
Method and system for determining the best integral process path to process semiconductor products to improve										
yield										
.						☐ All Fees				
	I					1.16 Fees (Filing)				
	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:									
FILING FEE					1.17 Fees (Processing Ext. of					
RECEIVED 790					time)					
/50					☐ 1.18 Fees (Issue)					
						Other				
						☐ Credit				

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